

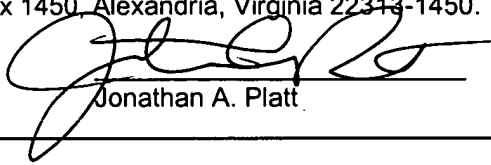


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Date: December 6, 2005


Jonathan A. Platt

Docket No. H1547

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Inventor: Tabery, et al.

Art Unit: 1756

Serial No.: 10/791,259

Examiner: Not yet assigned

Filing Date: March 2, 2004

Title: LITHOGRAPHY MASK UTILIZING ASYMMETRIC LIGHT SOURCE

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

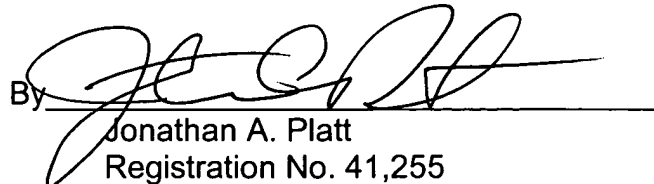
Sir:

The above-identified application has been on file since March 2, 2004. The applicant respectfully inquires as to when the application will be taken up for examination.

A prompt reply to this inquiry would be appreciated.

Respectfully submitted,

RENNER, OTTO, BOISSELLE & SKLAR, LLP

By 
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